# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
SHUNPEI YAMAZAKI	09/21/2010
JUNICHIRO SAKATA	09/30/2010
KOSEI NODA	09/30/2010
MASAYUKI SAKAKURA	09/23/2010
YOSHIAKI OIKAWA	09/30/2010
HOTAKA MARUYAMA	09/23/2010

#### **RECEIVING PARTY DATA**

Name:	SEMICONDUCTOR ENERGY LABORATORY CO., LTD.	
Street Address:	398, HASE	
City:	ATSUGI-SHI, KANAGAWA-KEN	
State/Country:	JAPAN	
Postal Code:	243-0036	

#### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	13870027

### **CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER: 12732-0682002 JANELLE A. JACKSON NAME OF SUBMITTER: **SIGNATURE:** /Janelle A. Jackson/ **DATE SIGNED:** 10/22/2014

**Total Attachments: 2** 

<del>PATENT</del> REEL: 034033 FRAME: 0517 source=Assignment - 12732-0682002#page1.tif source=Assignment - 12732-0682002#page2.tif

> PATENT REEL: 034033 FRAME: 0518

## ASSIGNMENT

For valuable consideration, We, Shunpei YAMAZAKI of Setagaya, Tokyo, Japan, Junichiro SAKATA of Atsugi, Kanagawa, Japan, Kosei NODA of Atsugi, Kanagawa, Japan, Masayuki SAKAKURA of Tochigi, Tochigi, Japan, Yoshiaki OIKAWA of Sagamihara, Kanagawa, Japan and Hotaka MARUYAMA of Tochigi, Tochigi, Japan hereby assign to Semiconductor Energy Laboratory Co., Ltd., a Japanese corporation having a place of business at:

398, Hase, Atsugi-shi, Kanagawa-ken, 243-0036 Japan

and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent signed by us this day, entitled <u>SEMICONDUCTOR DEVICE AND METHOD FOR</u> MANUFACTURING THE SAME, filed 4/25/2013, and assigned U.S. Serial Number 13/870,027, and we authorize and request the attorneys appointed in said application to hereafter complete this assignment by inserting above the filing date and serial number of said application when known; this assignment including said application, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignee to apply in all countries in our name or in its own name for patents, utility models, design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and we agree for ourselves and our respective heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment.

Signature

Name:

Shunpei YAMAZAKI

Date:

09/2//2010

Signature

Name: J

Date:

Junichiro SAKATA

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Kosei Voda Signature Name: Kosei NODA Date: Signature Name: Masayuki SAKAKURA 2010 Date: Signature Name: Yoshiaki OIKAWA Date: Signature Name: Hotaka MARUYAMA 09/23 / 2010 Date:

**RECORDED: 10/24/2014** 

PATENT REEL: 034033 FRAME: 0520